

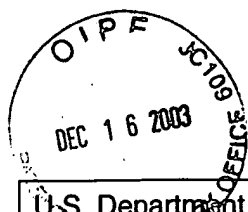
The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

The Applicants do not feel that a fee is necessary at this time, but if the sum of \$180.00 is due under 37 CFR § 1.17(p) pursuant to § 1.97, the Commissioner is hereby authorized to charge this fee, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/APPM/6766/BTP.

Respectfully submitted,



Robb D. Edmonds
Registration No. 46,681
MOSER, PATTERSON & SHERIDAN, L.L.P.
3040 Post Oak Blvd., Suite 1500
Houston, TX 77056
Telephone: (713) 623-4844
Facsimile: (713) 623-4846
Attorney for Applicants



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U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)		Docket No. APPM/6766	Serial No. 10/712,690
INFORMATION DISCLOSURE STATEMENT BY APPLICANT		Applicant Chen, et al.	Confirmation No.
(Use several sheets if necessary)		Filing Date November 13, 2003	Group
Examiner Unknown			

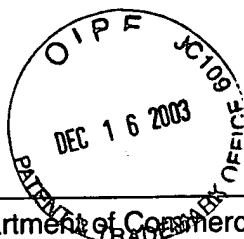
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	A2	6,511,539	01/28/2003	RAAIJMAKERS	117	102	09/08/1999
	A3	6,482,733	11/19/2002	RAAIJMAKERS, ET AL	438	633	04/26/2001
	A4	6,482,262	11/19/2002	ELERS, ET AL.	117	84	10/13/2000
	A5	6,481,945	11/19/2002	HASPER, ET AL.	414	217	06/04/1999
	A6	6,478,872	11/12/2002	CHAE, ET AL.	117	88	12/20/1999
	A7	6,475,910	11/05/2002	SNEH	438	685	09/22/2000
	A8	6,475,276	11/05/2002	ELERS, ET AL.	117	84	10/13/2000
	A9	6,468,924	10/22/2002	LEE, ET AL.	438	763	05/31/2001
	A10	6,451,695	09/17/2002	SNEH	438	685	12/22/2000
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	A12	6,447,607	09/10/2002	SOININEN, ET AL.	117	200	12/27/2000
	A13	6,416,577	07/09/2002	SUNTOLOA, ET AL.	117	88	12/09/1998
	A14	6,399,491	06/04/2002	JEON, ET AL.	438	680	04/06/2001
	A15	6,391,785	05/21/2002	SATTA, ET AL.	438	704	08/23/2000
	A16	6,379,748	04/30/2002	BHANDARI, ET AL.	427	255.394	01/17/2000
	A17	6,372,598	04/16/2002	KANG, ET AL.	438	399	06/16/1999
	A18	6,358,829	03/19/2002	YOON, ET AL.	438	597	09/16/1999
	A19	6,348,376	02/19/2002	LIM, ET AL.	438	253	01/19/2001
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	A21	6,306,216	10/23/2001	KIM, ET AL.	118	725	07/12/2000
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	A23	6,287,965	09/11/2001	KANG, ET AL.	438	648	02/23/2000
	A24	6,284,646	09/04/2001	LEEM	438	629	08/19/1998
	A25	6,270,572	08/07/2001	KIM, ET AL.	117	93	08/09/1999
	A26	6,231,672	05/15/2001	CHOI, ET AL.	118	715	05/18/1999
	A27	6,207,487	03/27/2001	KIM, ET AL.	438	238	10/12/1999

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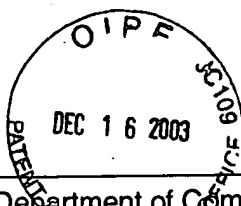
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	A3	6,197,683	03/06/2001	KANG, ET AL.	438	643	09/18/1998
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	A5	6,174,809	01/16/2001	KANG, ET AL.	438	682	12/15/1998
	A6	6,174,377	01/16/2001	DOERING, ET AL.	118	729	01/04/1999
	A7	6,144,060	11/07/2000	PARK, ET AL.	257	310	07/31/1998
	A8	6,139,700	10/31/2000	KANG, ET AL.	204	192.17	09/30/1998
	A9	6,124,158	09/26/2000	DAUTARTAS, ET AL.	438	216	06/08/1999
	A10	6,084,302	07/04/2000	SANDHU	257	751	12/26/1995
	A11	6,042,652	03/28/2000	HYUN, ET AL.	118	719	09/07/1999
	A12	6,015,917	01/18/2000	BHANDARI, ET AL.	556	12	01/23/1998
	A13	6,015,590	01/18/2000	SUNTOLA, ET AL.	427	255.23	11/28/1995
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	A18	5,835,677	11/10/1998	LI, ET AL.	392	401	10/03/1996
	A19	5,807,792	09/15/1998	ILG, ET AL.	438	758	12/18/1996
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	A21	5,711,811	01/27/1998	SUNTOLA, ET AL.	118	711	11/28/1995
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	A26	5,443,647	08/22/1995	AUCOIN, ET AL.	118	723 ME	07/11/1994

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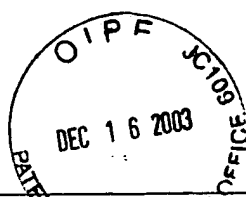
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	A2	5,374,570	12/20/1994	NASU, ET AL.	437	40	08/19/1993
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	A11	20030082296	05/01/2003	ELERS, ET AL.	427	96	09/12/2002
	A12	20030075925	04/24/2003	LINDFORS, ET AL.	285	367	06/28/2002
	A13	20030075273	04/24/2003	KILPELA, ET AL.	156	345.33	08/14/2002
	A14	20030072975	04/17/2003	SHERO, ET AL.	428	704	09/26/2002
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	A16	20030042630	03/06/2003	BABCOKE, ET AL.	261	121.1	09/05/2001
	A17	20030031807	02/13/2003	ELERS, ET AL.	427	569	09/17/2002
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	A21	20020187256	12/12/2002	ELERS, ET AL.	427	99	07/30/2002
	A22	20020182320	12/05/2002	LESKELA, ET AL.	427	250	03/15/2002
	A23	20020177282	11/28/2002	SONG	438	300	12/18/2001
	A24	20020164423	11/07/2002	CHIANG, ET AL.	427	255.28	05/03/2002
	A25	20020164421	11/07/2002	CHIANG, ET AL.	427	248.1	05/03/2002
	A26	20020162506	11/07/2002	SNEH, ET AL.	118	715	06/28/2002
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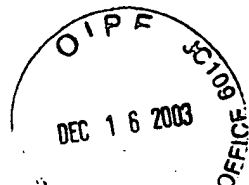
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	A4	20020134307	09/26/2002	CHOI	118	715	11/30/2000
	A5	20020108570	08/15/2002	LINDFORS	118	715	04/16/2001
	A6	20020106536	08/08/2002	LEE, ET AL.	428	702	02/02/2001
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	A9	20020094689	07/18/2002	PARK	438	694	03/07/2002
	A10	20020092471	07/18/2002	KANG, ET AL.	118	715	01/16/2002
	A11	20020086106	07/04/2002	PARK, ET AL.	427	248.1	11/07/2001
	A12	20020076837	06/20/2002	HUJANEN, ET AL.	438	3	11/28/2001
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	A14	20020076507	06/20/2002	CHIANG, ET AL.	427	569	10/24/2001
	A15	20020076481	06/20/2002	CHIANG, ET AL.	427	8	10/24/2001
	A16	20020073924	06/20/2002	CHIANG, ET AL.	118	723 R	10/24/2001
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	A19	20020052097	05/02/2002	PARK	438	507	05/03/2001
	A20	20020048635	04/25/2002	KIM, ET AL.	427	331	10/08/1999
	A21	20020041931	04/11/2002	SUNTOLA, ET AL.	427	255.28	05/14/2001
	A22	20020031618	03/14/2002	SHERMAN	427	569	10/09/2001
	A23	20020021544	02/21/2002	CHO, ET AL.	361	200	08/07/2001
	A24	20020020869	02/21/2002	PARK, ET AL.	257	306	12/20/2000
	A25	20020007790	01/24/2002	PARK	118	715	05/03/2001
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	A27	20020000196	01/03/2002	PARK	118	715	05/03/2001

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	A3	20010054377	12/27/2001	LINDFORS, ET AL.	117	104	04/16/2001
	A4	20010042799	11/22/2001	KIM, ET AL.	239	553	02/02/2001
	A5	20010042523	11/22/2001	KESALA	122	6.6	05/14/2001
	A6	20010041250	11/15/2001	WERKHOVEN, ET AL.	428	212	03/06/2001
	A7	20010034123	10/25/2001	JEON, ET AL.	438	643	04/06/2001
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	A9	20010025979	10/04/2001	KIM, ET AL.	257	315	12/04/2000
	A10	20010024387	09/27/2001	RAAIJMAKERS, ET AL	365	200	02/22/2001
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	A12	20010013312	08/16/2001	SOININEN, ET AL.	117	86	12/27/2000
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	A14	20010009695	07/26/2001	SAANILA, ET AL.	427	255.39	01/18/2001
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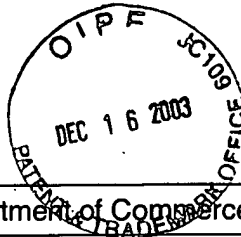
F Foreign Patent Documents

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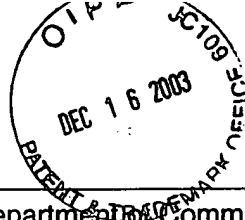
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	C2	Kukli, <i>et al.</i> "Atomic Layer Epitaxy Growth of Tantalum Oxide Thin Films from Ta(OC ₂ H ₅) ₅ and H ₂ O," Journal of the Electrochemical Society, Vol. 142, No. 5, May 1995; p. 1670-5
	C3	Kukli, <i>et al.</i> , "In situ Study of Atomic Layer Epitaxy Growth of Tantalum Oxide Thin Films From Ta(OC ₂ H ₅) ₅ and H ₂ O," Applied Surface Science, Vol. 112, March 1997, p. 236-42
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	C6	Ritala, M., <i>et al.</i> , "Chemical Vapor Deposition," January 1999, p. 6-9
	C7	Rossnagel, <i>et al.</i> "Plasma-enhanced Atomic Layer Deposition of Ta and Ti for Interconnect Diffusion Barriers," J. Vac. Sci. Technol. B., Vol. 18, No. 4 (July 2000); p2016-20
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	C9	Eisenbraun, <i>et al.</i> "Atomic Layer Deposition (ALD) of Tantalum-based materials for zero thickness copper barrier applications," Proceedings of the IEEE 2001 International Interconnect Technology Conference (Cat. No. 01EX461) 2001
	C10	Clark-Phelps, <i>et al.</i> "Engineered Tantalum Aluminate and Hafnium Aluminate ALD Films for Ultrathin Dielectric Films with Improved Electrical and Thermal Properties," Mat. Res. Soc. Symp. Proc. Vol. 670 (2001)

Examiner	Date Considered
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